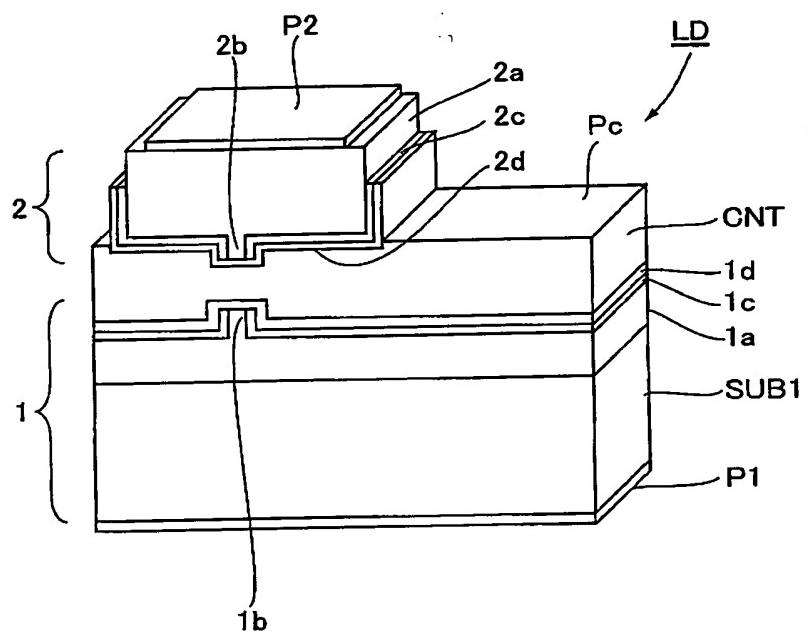
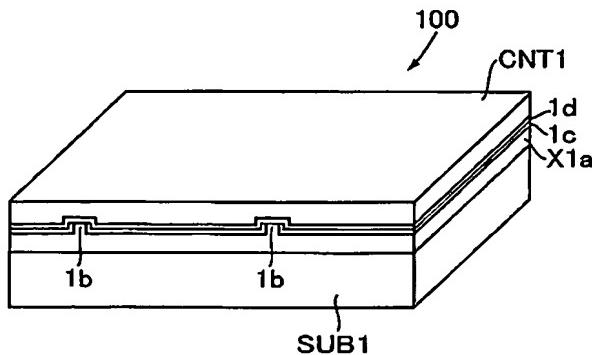


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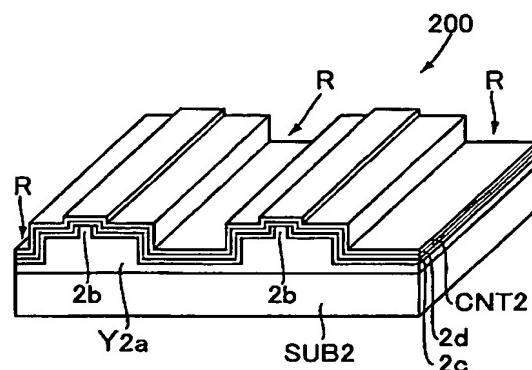
**FIG.1**



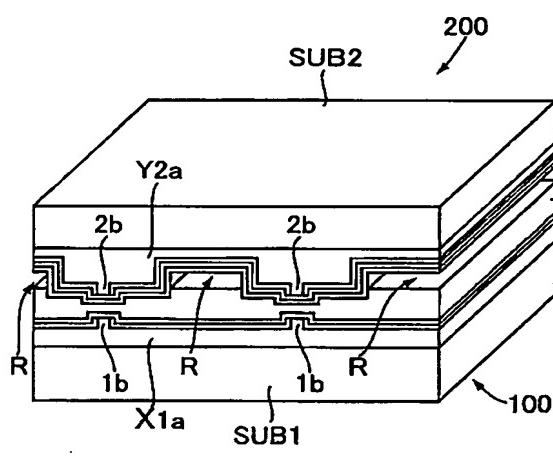
**FIG.2 (a)**



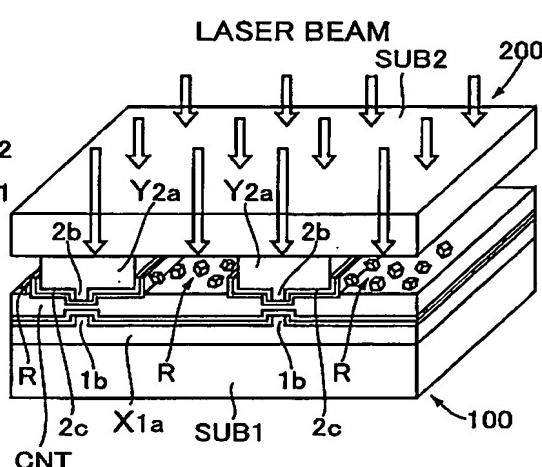
**FIG.2 (b)**



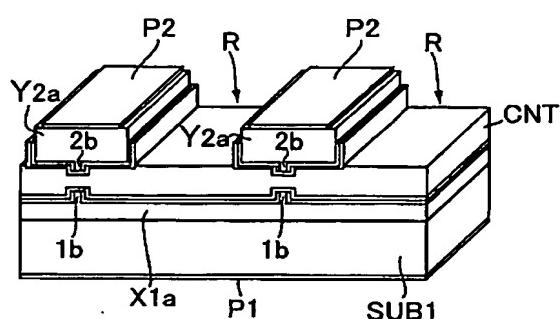
**FIG.2 (c)**



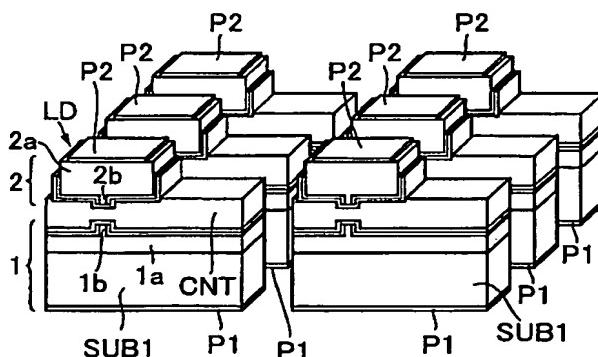
**FIG.2 (d)**



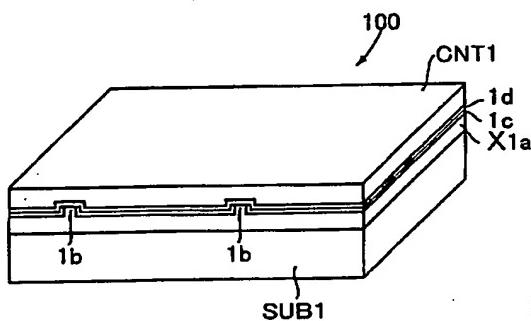
**FIG.2 (e)**



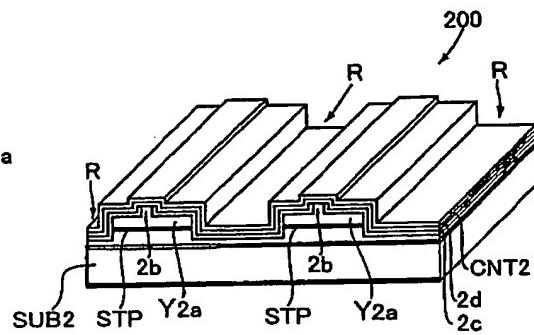
**FIG.2 (f)**



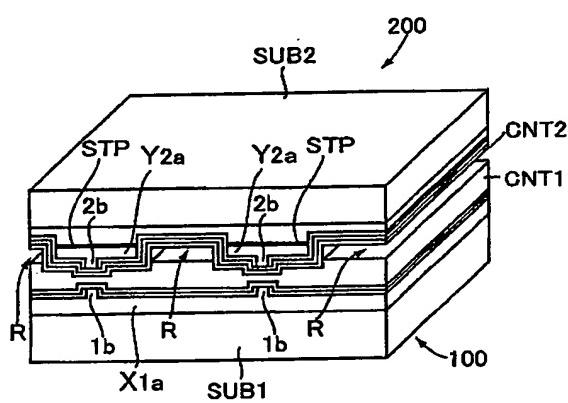
**FIG.3 (a)**



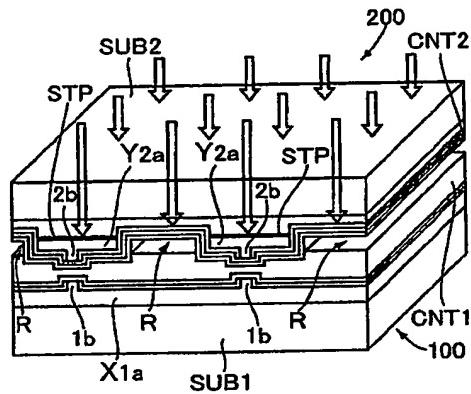
**FIG.3 (b)**



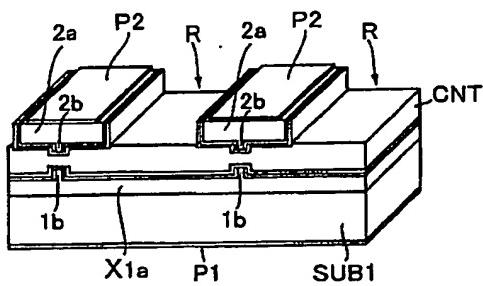
**FIG.3 (c)**



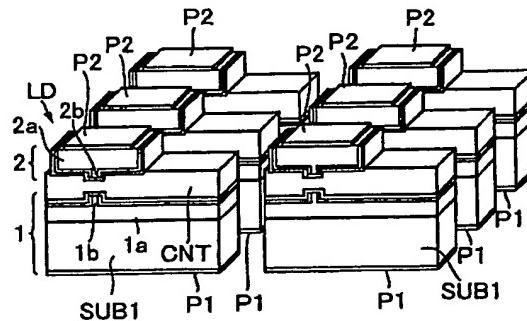
**FIG.3 (d)**



**FIG.3 (e)**

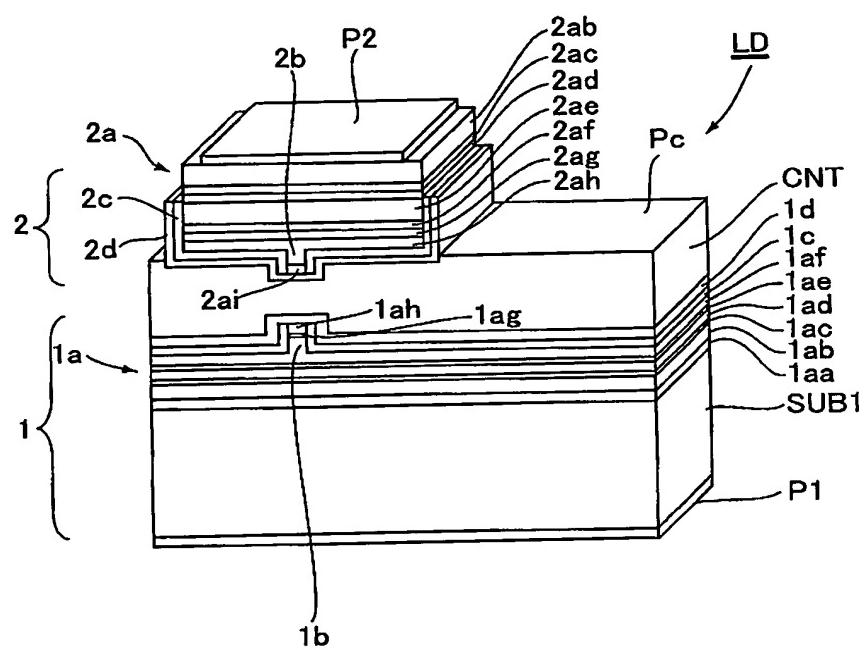


**FIG.3 (f)**

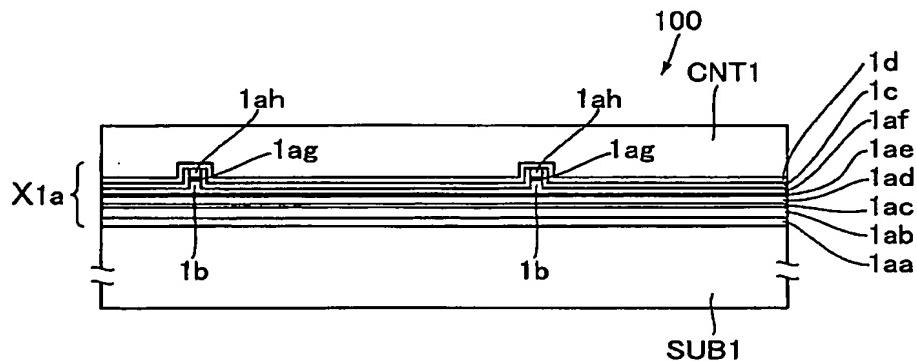


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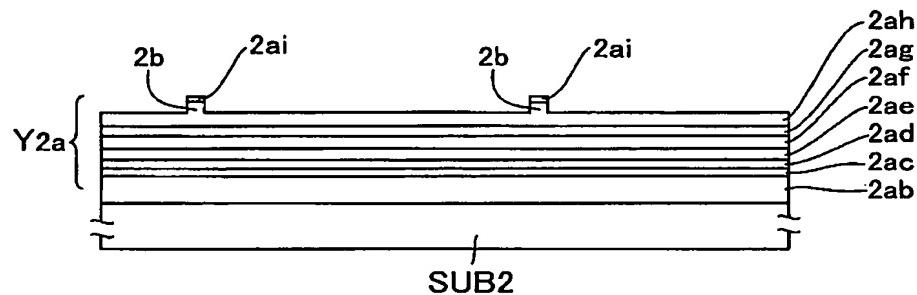
**FIG.4**



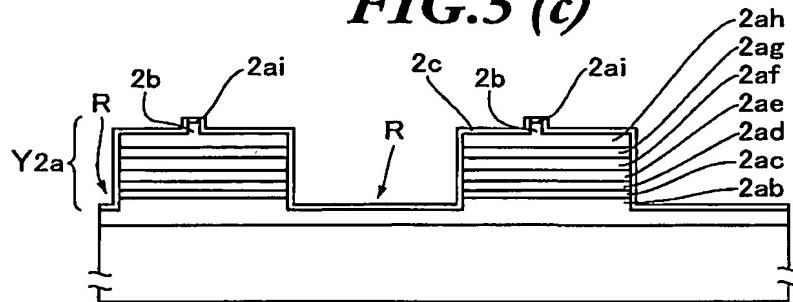
**FIG.5 (a)**



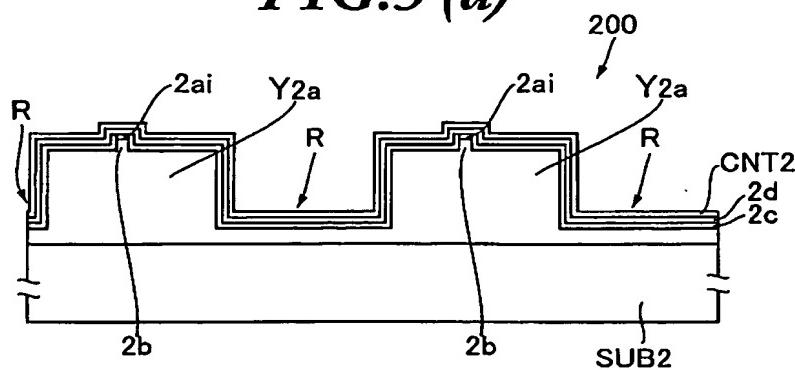
**FIG.5 (b)**



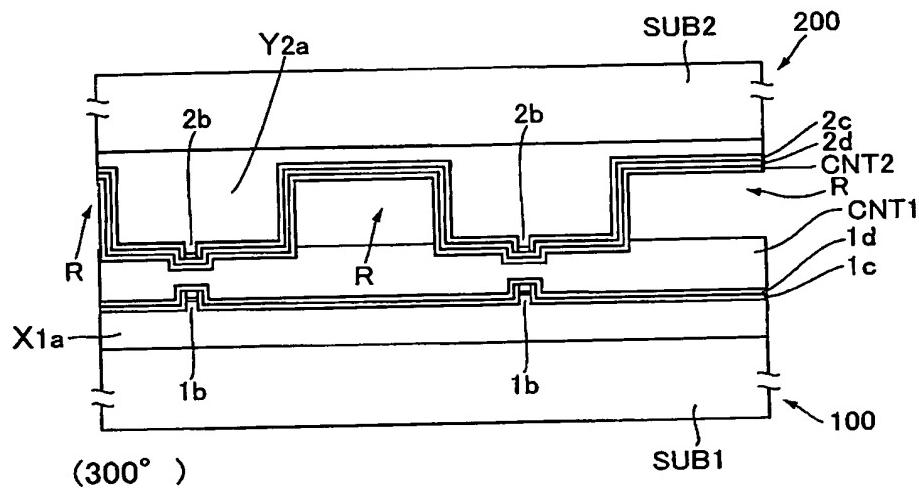
**FIG.5 (c)**



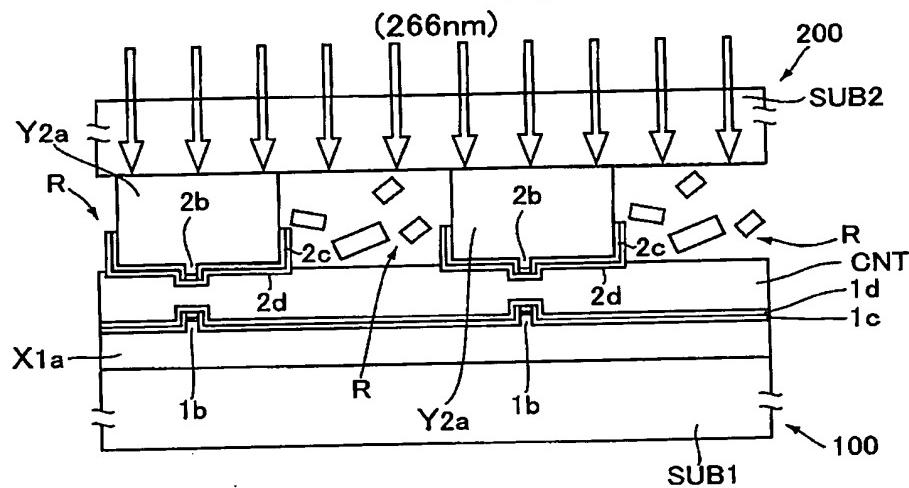
**FIG.5 (d)**



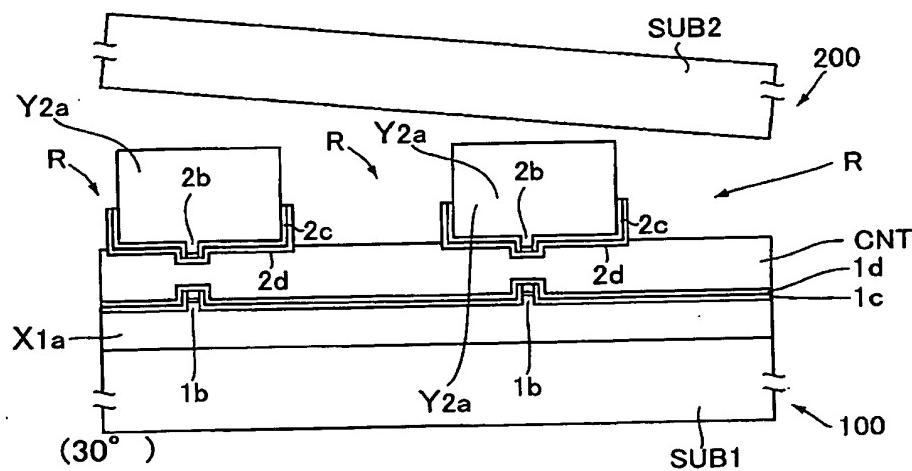
**FIG.6 (a)**



**FIG.6 (b)**

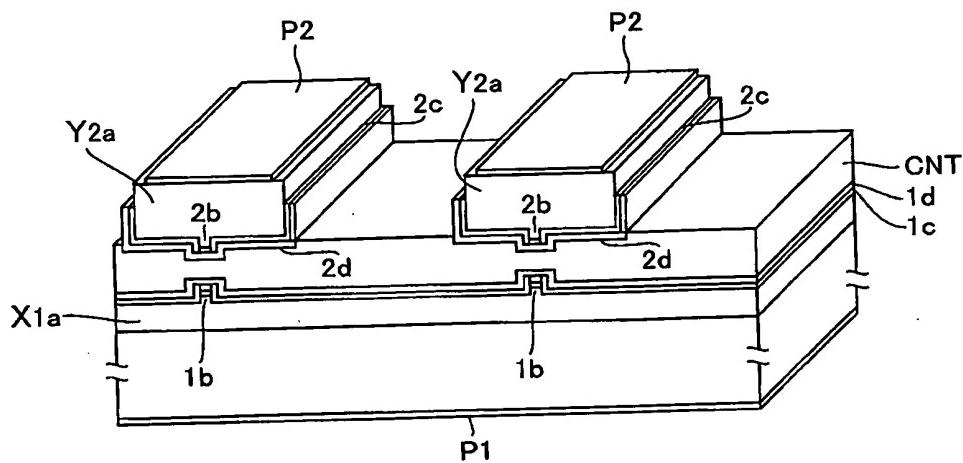


**FIG.6 (c)**

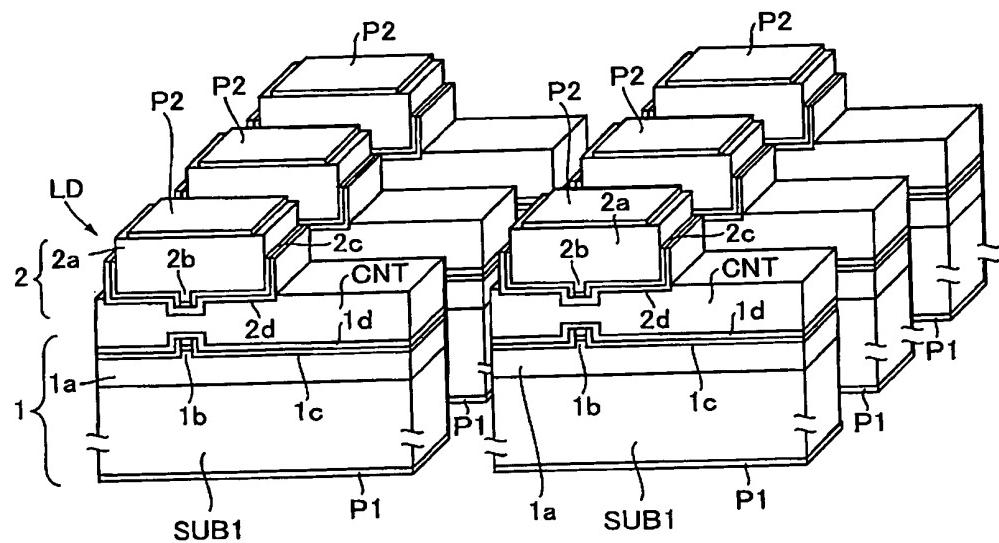


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**FIG.7 (a)**

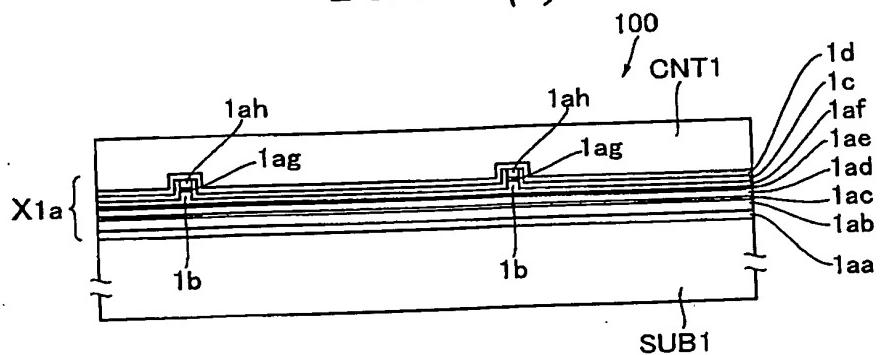


**FIG.7 (b)**

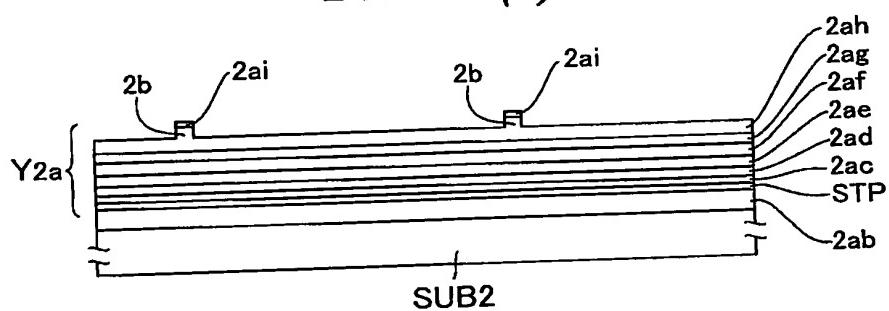


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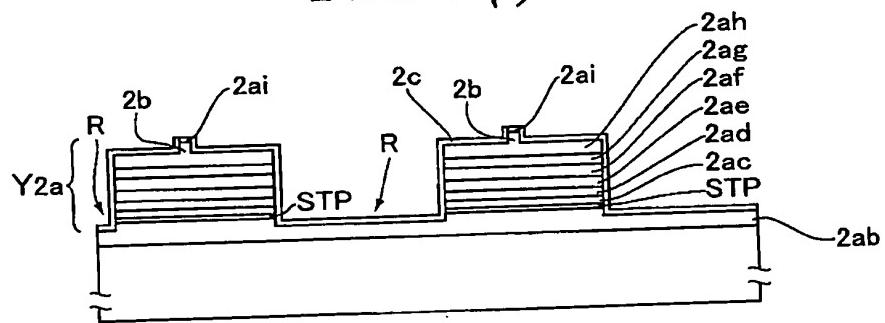
**FIG.8 (a)**



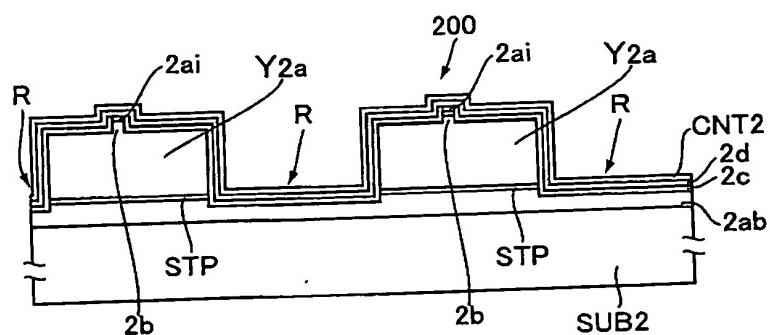
**FIG.8 (b)**



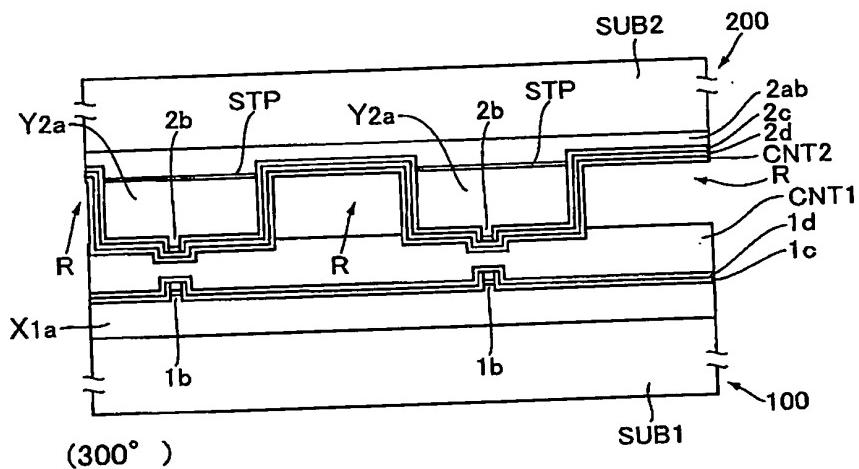
**FIG.8 (c)**



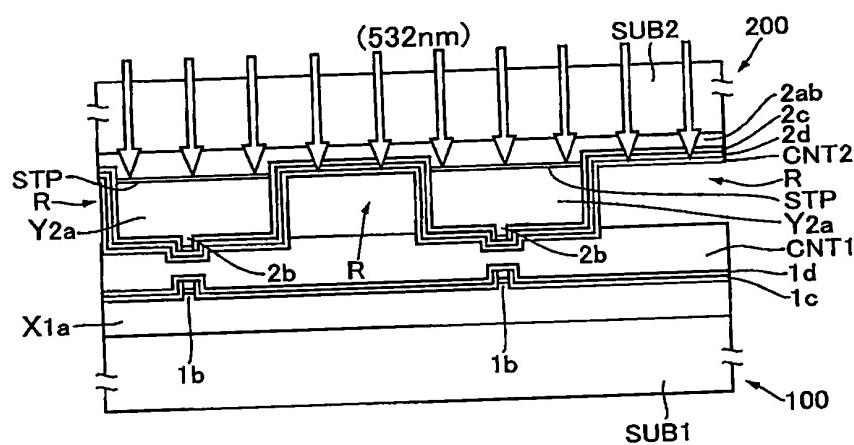
**FIG.8 (d)**



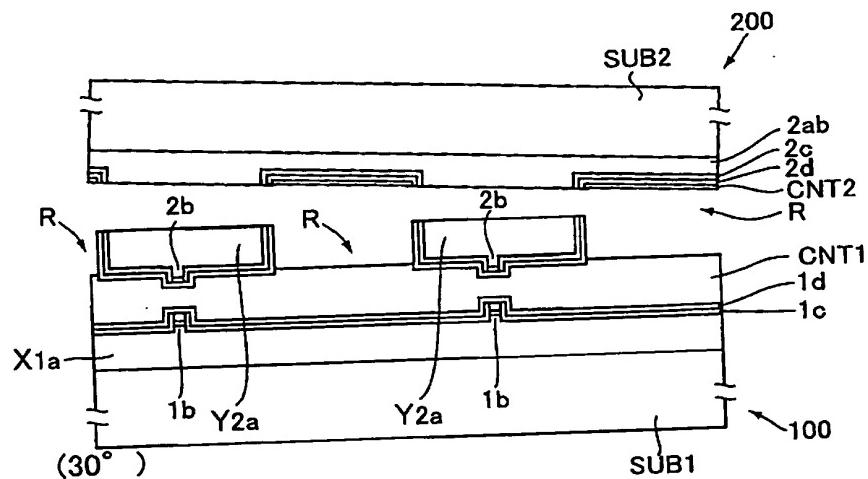
**FIG.9 (a)**



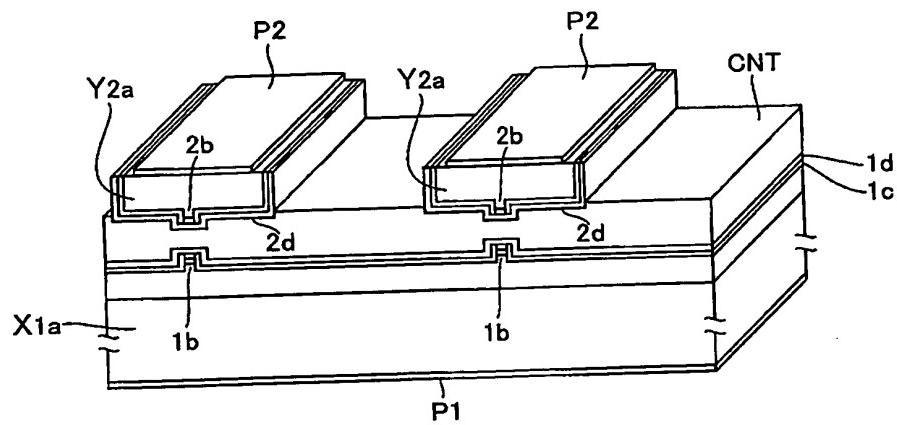
**FIG.9 (b)**



**FIG.9 (c)**



**FIG.10 (a)**



**FIG.10 (b)**

